

Title (en)

GAS-TIGHT ELECTROLYTE LAYER AND METHOD FOR THE PRODUCTION THEREOF

Title (de)

GASDICHTE ELEKTROLYTSCHICHT SOWIE VERFAHREN ZUR HERSTELLUNG

Title (fr)

COUCHE D'ELECTROLYTE ETANCHE AUX GAZ ET SON PROCEDE DE PRODUCTION

Publication

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Application

EP 05814342 A 20051028

Priority

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Abstract (en)

[origin: WO2006050692A2] The invention relates to a method for producing a gas-tight solid electrolyte layer, in which an electrolyte layer that is applied to a substrate and is unsintered or has been presintered at temperatures below 1150^oC is first infiltrated at least once with a fluid containing zirconium and is dried and optionally baked. The fully infiltrated electrolyte layer is then sintered at temperatures lying below 1400^oC. The electrolyte layer produced according to the inventive method is advantageously provided with very low leakage rates of less than 5*10⁻⁵ mbar¹/s¹cm², which are determined at a differential pressure of 100 mbar by means of a helium leakage test apparatus.

IPC 8 full level

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See references of WO 2006050692A2

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